12-9-04

TFW

ractitioner's Docket No.: 789\_127

**PATENT** 

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Yukihisa TAKEUCHI, Tsutomu NANATAKI, Iwao

OHWADA and Takayoshi AKAO

Ser. No.: 10/810,078

Art Unit: 2673

Filed: March 26, 2004

Examiner: Bipin H. Shalwala

Confirmation No.: 3510

For:

CIRCUIT ELEMENT, SIGNAL PROCESSING CIRCUIT, CONTROL DEVICE,

DISPLAY DEVICE, METHOD OF DRIVING DISPLAY DEVICE, METHOD OF

DRIVING CIRCUIT ELEMENT, AND METHOD OF DRIVING CONTROL

**DEVICE** 

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 8, 2004 under "EXPRESS MAIL" mailing label number EV 48855 8733 US.

Janet M. Stevens

# INFORMATION DISCLOSURE STATEMENT AND IDENTIFICATION OF COPENDING APPLICATIONS

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Required copies of the references listed on Form PTO-1449 are attached.

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The attention of the Patent Office is also drawn to the related copending applications listed on the attached Form PTO-1449 which may contain technical subject matter related to that of the present invention. This identification is not to be construed as a waiver of secrecy as to the cited applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination of the present application.

The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-1446.

Respectfully submitted,

December 8, 2004

Date

Stephen P. Burr

Reg. No. 32,970

SPB:jms

BURR & BROWN P.O. Box 7068

Syracuse, NY 13261-7068

Customer No.: 025191

Telephone: (315) 233-8300 Facsimile: (315) 233-8320

ctitioner's Docket No.: 789 127

**PATENT** 

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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### TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT **UNDER 37 CFR §1.97(b)**

Sir:

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The information disclosure statement transmitted herewith is being filed:

[ ] within three months of the filing date of this national application.

within three months of the date of entry of the national stage as set forth in §1.491 in an international application.

[X] before the mailing date of the first Office action on the merits.

[ ] before the mailing of a first Office Action after the filing of a request for continued examination under §1.114.

Respectfully submitted,

December 8, 2004

Date

Reg. No. 32,970

SPB:jms **BURR & BROWN** P.O. Box 7068 Syracuse, NY 13261-7068

Customer No.: 025191 Telephone: (315) 233-8300

Facsimile: (315) 233-8320

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Form PTO-14	149	7	C119		Complete if Known	
US DEPARTME	NT OF COMMERCE	DEC 0	8 2004 H	Application Number	10/810,078	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	March 26, 2004	
				First Named Inventor	Yukihisa TAKEUCHI	
SIAIL	VII IJ X	ATTLIC	ANI	Art Unit 2673		
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Sheet	1	of	3	Attorney Docket No.	789_127	-

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Examiner:	Date Considered:	

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449				Complete if Known		
	ENT OF COMMERC			Application Number	10/810,078	
				Filing Date	March 26, 2004	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT			First Named Inventor	Yukihisa TAKEUCHI	
SIAIL	MILINI DI	AIILIC	AIVI	Art Unit	2673	
		<b>.</b>		Examiner Name	Bipin H. Shalwala	
(use as many sheets as necessary)		Confirmation No.	3510			
Sheet	2	of.	3	Attorney Docket No.	789_127	

### U.S. RELATED COPENDING APPLICATIONS

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Examiner: Date Con	sidered:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

	Form PTO-1449 US DEPARTMENT OF COMMERCE			Complete if Known			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number Filing Date	10/810,078 March 26, 2004		
	(use as many sheets as necessary)			First Named Inventor	Yukihisa TAKEUCHI		
	,		**	Art Unit	2673		
				Examiner Name	Bipin H. Shalwala		
			Confirmation No.	3510			
Sheet	3	of	3	Attorney Docket No.	789_127		

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Examiner:		Date Considered:	